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## Novel fabrication of mixed wettability micromodels for pore-scale studies of fluid–rock interactions

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Wettability plays a crucial role in multiphase fluid flow in porous media, impacting various geological applications such as hydrocarbon extraction, aquifer remediation, and carbon dioxide sequestration. Microfluidic methods have attracted interest for their capacity to explore and visualize essential multiphase flow dynamics at the pore level, mimicking actual rock pore structures. However, creating micromodels with representative mixed wettability is currently a challenge. Existing technology is limited to producing micromodels with a singular wettability, either water-wet or oil-wet, leaving a gap in representing mixed-wet scenarios. In this study, we introduce a novel method to fabricate microfluidic devices with controlled spatial distribution of wettability at the micro-scale, mimicking actual configurations of mixed-wet rocks arising from varied mineralogy and pore structures. The proposed method combines the soft lithography process with thin film deposition techniques. The micromodels were designed to mimic the pore network of actual reservoir rocks, and a silicon substrate served as the foundation for the photolithography process optimization and wettability alteration methodology. Perfluorodecyltrichlorosilane coating was applied using molecular vapor deposition technology for surface wettability modification. The coated parts of the microdevice substrate altered the localized wetting state of the silicon towards hydrophobic, while the wettability remained unchanged in the non-coated areas. We utilized surface measurements, including contact angle, X-ray photoelectron spectroscopy, transmission electron microscopy, scanning electron microscopy, and atomic force microscopy, to assess the wettability, composition, thickness, shape, roughness, and overall quality of the coating. Our fabrication process successfully produced a microfluidics device with tailored mixed-wet attributes at the micro-scale, which is, to our best knowledge, the first achievement in the field. This method enables the replication of mixed-wet characteristics commonly seen in various applications, such as carbonates and shales within underground rocks, providing a more accurate examination of fundamental multiphase fluid dynamics and rock interactions at the pore level.

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## Introduction

Wettability is a critical rock–fluid property that exerts a substantial influence on multiphase flow dynamics, influencing a spectrum of geological applications, such as oil recovery,<sup>1,2</sup> water infiltration processes,<sup>3</sup> and carbon underground storage,<sup>4</sup> among others. It plays a substantial role in rock–fluid interaction, impacting fundamental mechanisms like capillary pressures, relative permeabilities, residual saturations, and imbibition processes.<sup>5–7</sup> These mechanisms drive the dynamics of fluid displacement, distribution, and capillary trapping.<sup>8,9</sup> Therefore,

understanding the complexity of rock wettability and fluid behavior at the pore level and alteration in the wettability of a solid surface is of broad interest.<sup>10,11</sup>

Wettability refers to the relative affinity of a solid surface towards a fluid, which determines the ability of the fluid to spread over or adhere to the surface in the presence of other immiscible fluids.<sup>12</sup> In porous media with uniform wettability and the presence of at least two immiscible fluids, the wetting fluid exhibits a stronger inclination to adhere to the surface. This preference dictates the interaction of the wetting and nonwetting fluids at the rock surface.<sup>13</sup> The solid's affinity for a fluid undergoes significant variations depending on the fluid and rock properties within the reservoir. These variations occur at both microscopic and macroscopic scales, which pose limitations when attempting to categorize reservoirs as either strictly hydrophilic (water-wet) or hydrophobic (oil-wet).<sup>14</sup> In the case of homogeneous

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wettability, the entire rock surface exhibits a uniform affinity for either water or oil. On the other hand, heterogeneous wettability (commonly referred to mixed, fractional, or spotted wettability) indicates the presence of distinct water and oil-wet regions coexisting on the surface of the porous media.<sup>15</sup>

Numerous studies indicated that the majority of reservoir rocks tend to exhibit a mixed-wet nature.<sup>16</sup> Rock wettability can be altered by the deposition of adsorbable organic components, such as asphaltenes.<sup>17–19</sup> Therefore, different regions of the rock can have varying wettability properties caused by the presence of certain surface-active components, which can alter the surface chemistry of the rock. Furthermore, the rock's pore composed of multiple minerals can possess different surface chemistry and adsorption properties, leading to heterogeneous wettability.<sup>20,21</sup> Fig. 1 shows a thin section of a rock with different mineral compositions. Different organic (*e.g.*, kerogen) and non-organic (*e.g.*, calcite, quartz, clay) matters coexist within the core sample, leading to spatial variations in the rock surface affinity toward different fluids.

The presence of heterogeneous (mixed) wettability distribution within natural rock formations introduces complexity to fluid flow dynamics, particularly in multiphase flow scenarios. While the existence of mixed wettability is known in the literature, its pore-scale effects on fluid flow are not fully understood.<sup>23</sup> Recent studies on multiphase fluid

flow in porous formations with mixed wettability have shown a significant impact on capillary pressure and saturation distribution,<sup>24–29</sup> which may lead to variations in reservoir performance. The complexity of mixed wettability makes it challenging to accurately assess its impact, as it may get confused with single water-wet and oil-wet scenarios.<sup>32</sup> Therefore, incorporating mixed wettability into pore network models, supported by representative experiments, is key to reducing uncertainties and improving predictions of pore-scale models.<sup>29–31</sup> Establishing a robust platform that allows for pore-scale observation and studies under representative conditions of mixed wettability systems is of broad interest.<sup>22</sup>

Core-flood experiments, traditionally used to study mixed wettability effects on subsurface rock flow, face limitations. These experiments are time-intensive, and the core material's opaqueness prevents direct observation, leading to reliance on core outlet data which could miss key flow physics within the core. Although 3D X-ray microtomography has improved our understanding of multiphase flow in porous media,<sup>33–35</sup> core-scale experiments remain costly, time-intensive, and interpretation is limited by X-ray imaging constraints.

Microfluidics, on the other hand, has emerged as a promising technology to study various aspects of multiphase fluid flow at the pore scale. It has gained attention due to its ability to mimic representative pore-size models and capture detailed observations of fluid dynamics within the porous network of rocks at high spatial resolution.<sup>36–39</sup> Microfluidics

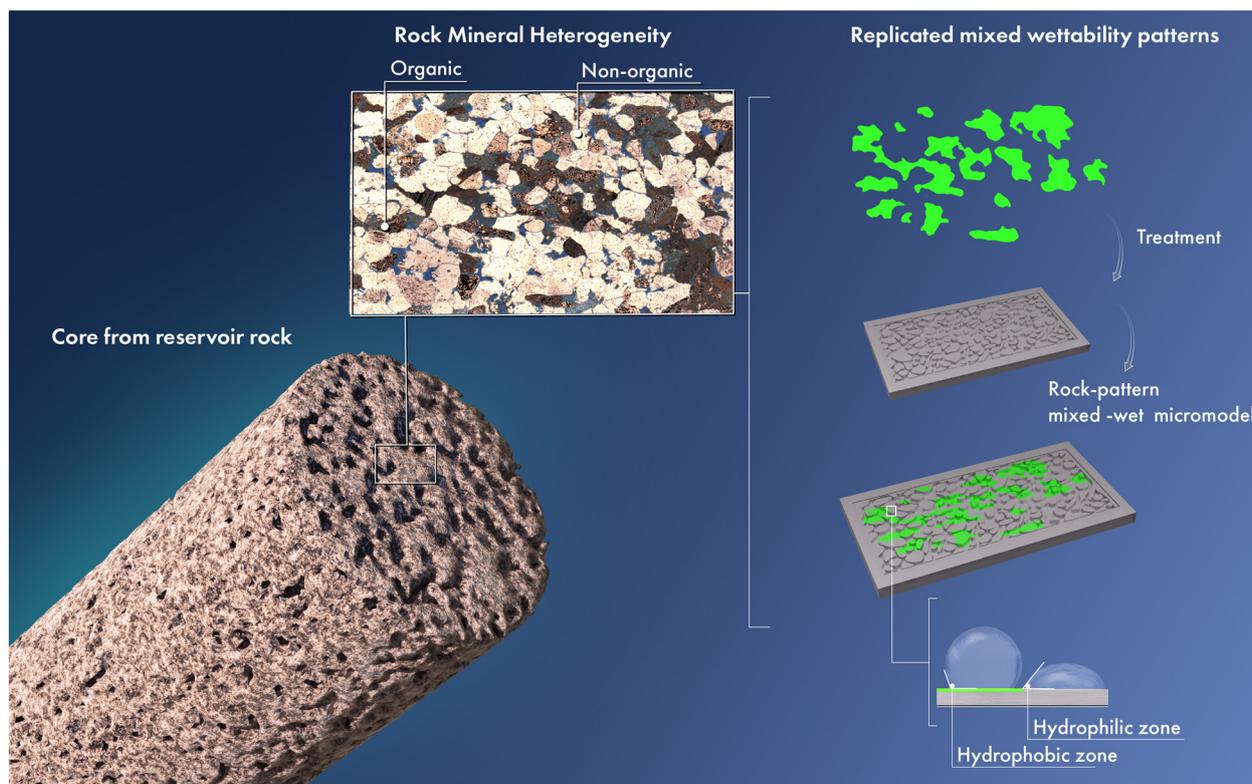


Fig. 1 Schematic illustration of a micromodel with spatial wettability variation mimicking a thin section of a reservoir rock with heterogeneous mineralogy.



also enables rapid, precise, and real-time analysis of fluid transport and phase behavior.<sup>40–44</sup> Micromodel substrates are utilized as 2D proxies to represent the complex 3D porous structures found in rocks, simplifying the analysis of pore-scale mechanisms. These 2D models, despite not completely replicating 3D flow and transport effects like the percolation threshold, offer a controlled environment with precise pore geometries. This control reduces the uncertainties present in natural 3D media and enables direct observation of fluid behaviors at the pore level.<sup>45</sup> Furthermore, the ability to produce identical models enhances the reproducibility of experiments, allowing for more consistent and reliable comparisons between different studies.

Standard microfluidic devices are primarily fabricated using materials like silicon, glass, and polymers, which may not fully replicate the physical and geochemical properties of natural rocks.<sup>46</sup> Several studies reported diverse approaches and materials employed to modify the surface wettability of micromodels, aiming to replicate the properties and behavior of reservoir rocks.<sup>47</sup> On the other hand, the establishment of micromodels with precisely controlled mixed wettability properties remains an unresolved challenge. Limited literature has documented efforts to construct micromodels with engineered materials to achieve mixed-wet characteristics. Zhao *et al.* introduced a technique to tune the wettability of photocurable thiolene-based microfluidic devices by adjusting the ultraviolet (UV) exposure, creating a uniform wetting state.<sup>48</sup> Lee *et al.* introduced a technique using UV-initiated polymer grafting to copolymerize hydrophilic and oleophilic microstructures through a bottom-up fabrication approach.<sup>49</sup> However, this technique is not fully representative of mixed wettability where different water-wet and oil-wet regions coexist on the same pore surface. In another study, Chang *et al.* employed octadecyltrichlorosilane dissolved in hexane as an invading fluid to alter the wettability of an ethylene glycol-saturated micromodel. This process yielded heterogeneous micromodel systems with partially coated surfaces exhibiting mixed-wet properties.<sup>50</sup> However, a notable limitation of this work lies in the lack of precise control over the location of wettability alteration and the reproducibility of data. In recent work, Irannezhad *et al.* made improvements by employing UV-ozone treatment to generate distinct water-wet clusters within oil-wet porous media. This work offered valuable insights into the characteristics and intricacies of mixed-wet porous media.<sup>51</sup> The challenge of attaining precise, selective mixed-wet properties, particularly on complex and irregular surfaces, remains an ongoing challenge. This entails careful selection of material, deposition methodologies, and surface treatment processes to establish the desired mixed-wet conditions.

This study introduces a new advanced method for fabricating microfluidic models with customized mixed-wettability surfaces, enabling precise spatial control over mixed wettability distribution. The proposed technique integrates the photolithography process and thin film

deposition as part of a nanofabrication approach. Perfluorodecyltrichlorosilane (FDTS) was chosen for deposition due to its effective reduction of adhesion on micro/nanostructures, creating hydrophobic coatings on silicon surfaces.<sup>52</sup> This work marks the first instance of fabricating a mixed-wet micromodel system, holding promise for replicating the actual wettability configuration of an oil reservoir at the pore scale. The unique aspect of this work is the ability to precisely control the size, shape, and location of both hydrophilic and hydrophobic regions on the surface of complex micromodel patterns, achieving high resolution down to 1  $\mu\text{m}$ . The technique relies on highly reliable and controlled nanofabrication, positioning it as an integrable method for microfluidics nanofabrication. It accommodates various wettability alteration designs, fostering a broad spectrum of studies on two-phase flow under controlled conditions. Such a comprehensive workflow is pivotal for gaining insights into wettability-dependent phenomena at both microscopic and macroscopic levels. Moreover, its applications extend beyond multiphase fluid flow in porous media to encompass fluid–surface interactions in biology, biomedical research, and electronics.

## Background

### Wettability

Contact angle measurements are commonly employed to evaluate surface wettability, involving the quantification of angles formed at the interface between the solid surface and coexisting fluids. These measurements offer insights into the interfacial tensions between the fluids and the solid, facilitating the assessment of surface wettability. The contact angle is typically determined based on the denser phase, often water, and is governed by Young's equation, which establishes a relationship between the contact angle and interfacial tensions:<sup>53</sup>

$$\cos \theta = \frac{\sigma_{\text{NWS}} - \sigma_{\text{WS}}}{\sigma_{\text{WNW}}} \quad (1)$$

Here,  $\sigma_{\text{NWS}}$  represents the interfacial tension between the non-wetting phase (*e.g.*, air) and the surface,  $\sigma_{\text{WS}}$  represents the interfacial tension between the wetting phase (*e.g.*, water) and the surface, and  $\sigma_{\text{WNW}}$  is the interfacial tension between the wetting and non-wetting phases (*e.g.*, water and air). The contact angle ( $\theta$ ) is the angle at the interface between the two fluids and the solid surface. As a general convention, a surface is considered hydrophilic (water-wet) when  $\theta$  is less than  $90^\circ$ , while it is regarded as hydrophobic (air-wet) when  $\theta$  exceeds  $90^\circ$ . When  $\theta$  is approximately  $90^\circ$ , it suggests a neutral wetting state.

### Surface silanization

Among numerous surface coating and modification methods, self-assembled monolayer (SAM), composed of organosilanes, exhibit significant potential for wettability alteration. Their notable attributes include excellent bonding strength, low



surface energy, minimal friction forces, and high thermal stability, rendering them highly attractive for various applications.<sup>54</sup> Organosilane SAM is an organic thin film of molecular assemblies, typically a few nanometers thick, formed by the spontaneous adsorption of molecules onto a substrate surface.<sup>55</sup> Organosilane SAM can be deposited from either liquid or vapor processes. Although liquid-phase SAM growth is more commonly employed, it is associated with notable drawbacks, including complexity in process control, the potential for influent solution contamination, and reduced deposition efficiency.<sup>56</sup>

In contrast, vapor-phase deposition, which eliminates the need for solvents, addresses the limitations of liquid-based processes. Vapor-phase deposition offers precise control over precursor chemistry, ensuring the desired hydrophobic properties. It facilitates efficient mass transport, leading to optimal coating uniformity and excellent coverage, even on high-aspect-ratio structures. Additionally, self-limiting surface reactions in vapor-phase deposition result in durable and conformal monolayer coverage.<sup>57</sup> Consequently, the vapor-phase deposition has been chosen as the preferred deposition technique in this study.

### FDTS deposition mechanism

FDTS, an organosilane precursor, possesses a trichlorosilane-based head group and an aliphatic fluorinated tail. The FDTS SAM deposition process starts with a hydrated silicon surface, where the presence of hydroxyl (OH) groups on the oxidized surface provides reactive sites for the formation of the chlorosilane SAM. In the initial step, the active trichlorosilane head groups ( $-\text{SiCl}_3$ ) undergo hydrolysis *via* water vapor ( $\text{H}_2\text{O}$ ) to form silanol groups ( $\text{Si}-\text{OH}$ ).

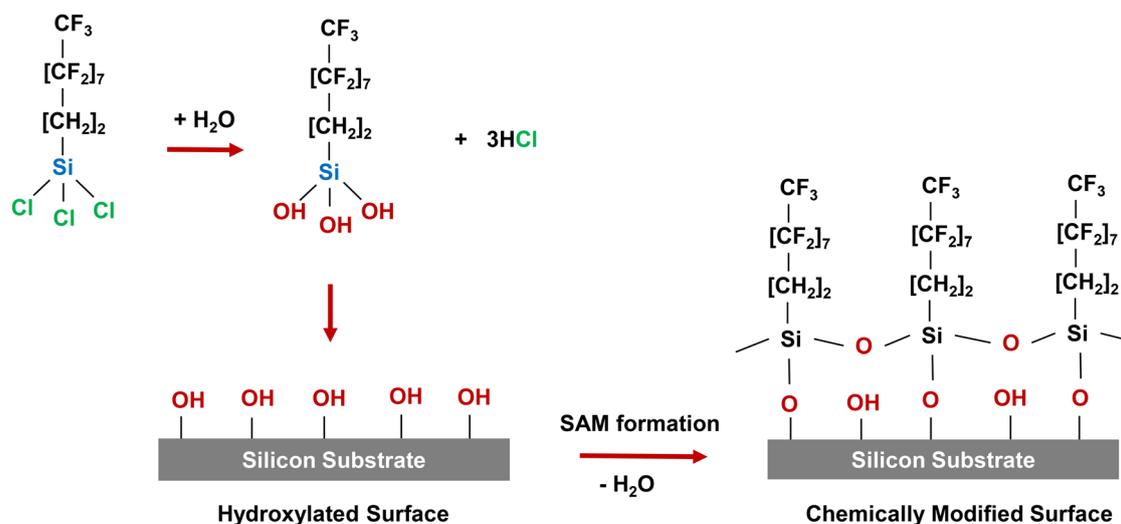
Subsequently, in the second step, the molecules' chains anchor and chemically bond to the substrate surface through the reaction of ( $-\text{SiOH}$ ) groups with ( $-\text{OH}$ ) groups on the hydrated silicon substrate, forming a highly stable covalent bond. The adsorbed molecules assemble and organize spontaneously on the surface. Assembled chains on the surface pack tightly with each other by lateral bonding due to van der Waals forces. The FDTS SAM film continues to grow until the substrate is fully covered by the single monolayer, as illustrated in Fig. 2.

## Materials and experimental procedure

### Materials

Deionized water (DI) was acquired from the Milli-Q water purification system provided by MilliporeSigma Company. The substrate used as a base for fabrication consisted of a 4-inch P-type (B-doped) prime-grade silicon wafer with a thickness of  $525 \pm 20 \mu\text{m}$  and an ohmic resistance of 10–20 ohm cm. The light-sensitive materials (AZ nLOF 2070 photoresists) were provided by Microchemicals. Hexamethyldisilazane (HMDS) was used as an adhesion promoter of photoresist to the silicon surface. AZ 726 MIF photoresist developer for fast and homogeneous substrate wetting and photoresist removal was obtained from Merck. The silicon substrate underwent cleaning using a Piranha acidic solution, composed of a mixture of 3 parts 96% vol. sulfuric acid ( $\text{H}_2\text{SO}_4$ ) and 1 part 30% vol. hydrogen peroxide ( $\text{H}_2\text{O}_2$ ). Additionally, a buffered oxide etch (BOE) was employed, which consists of a blend of hydrofluoric acid (HF) and ammonium fluoride ( $\text{NH}_4\text{F}$ ). Perfluorodecyltrichlorosilane (FDTS) obtained from Gelest was employed for coating. The *n*-methyl-2-pyrrolidone (NMP)

### FDTS Precursor



**Fig. 2** Illustration of surface modification by FDTS and formation of FDTS SAM film on a silicon surface. FDTS precursors hydrolyze and chemically bond to the hydrated silicon surface. The adsorbed molecules assemble spontaneously on the surface and continue to grow until FDTS SAM film fully covering the surface (modified from ref. 58).



and isopropyl alcohol (IPA) solvents were used for photoresist lift-off.

### Mixed wettability coating and fabrication methodology

The proposed methodology presents a novel approach to fabricating micromodels with mixed wettability. It combines both the photolithography process and thin film deposition technique, utilizing a nanofabrication approach. A silicon substrate served as the foundation for the photolithography process optimization and wettability alteration methodology. This method allows for the creation of hydrophobic surfaces in specific regions by modifying the original wetting surface properties of the silicon substrate. The alteration of surface wettability is achieved by selectively applying a hydrophobic FDTs SAM on top of the micromodel surface. The shape, size, and placement of the deposited layer are precisely controlled using a wettability pattern control photomask, which guides the deposition process by replicating the provided patterns. To induce the wettability alteration on the surface, predefined wettability patterns are initially designed on a photomask using CleWin5 software. The physical photomask is created by directly writing the digital design and performing high-resolution laser patterning on a five-inch glass plate coated with a 100 nm-chrome layer using the Heidelberg DWL 2000 laser lithography system. The

fabricated wettability photomask is transparent, with chrome patterns defining the wettability distribution. This allows the light to shine only through unmasked transparent areas while being blocked in the covered areas with chrome, which controls the required wettability features. Fig. 3 provides a detailed description of the workflow employed to establish the selective surface coating and fabricate the mixed wettability micromodel surface.

The workflow consists of six main steps:

- In the first step, the surface of micromodel is preconditioned by cleaning the substrate using a piranha solution at  $T = 115\text{ }^{\circ}\text{C}$  for 10 minutes to remove contamination. Additionally, it is an effective method to create an OH-terminated surface. This oxidation process is essential for achieving a high-quality SAM coating.<sup>54</sup> The substrate is then dehydrated by baking at  $T = 150\text{ }^{\circ}\text{C}$  for 10 minutes on direct contact hotplate to eliminate surface moisture. To facilitate photoresist adhesion to the substrate surface, the surface is activated with an HMDS adhesion promoter at  $T = 150\text{ }^{\circ}\text{C}$  in vacuum chamber.

- In the second step, the surface is spin-coated with a  $7\text{ }\mu\text{m}$  layer of AZ-nLOF 2070 negative photoresist at 2500 rpm spinning speed. The thickness of the photoresist is optimized based on the viscosity of the photoresist and the spinning speed to ensure that the photoresist evenly covers the micromodel patterns, allowing for controlled lithography

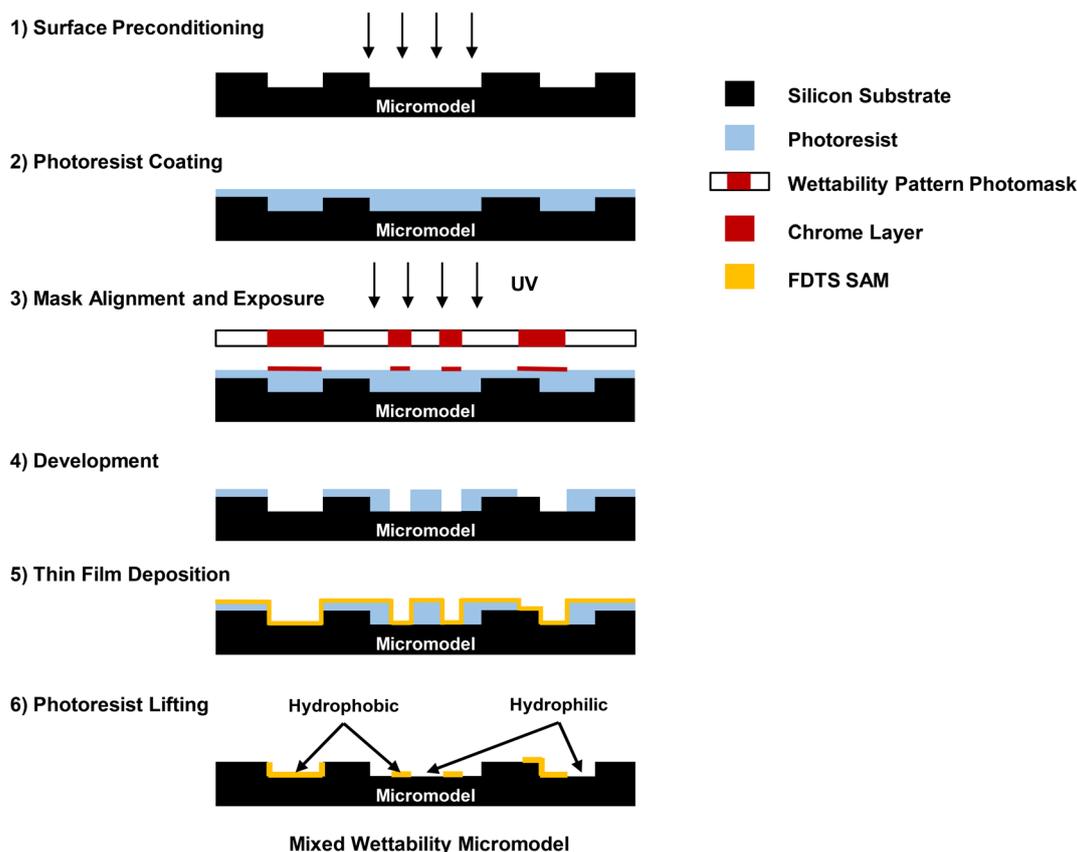


Fig. 3 Illustration of the 6-step workflow developed to achieve mixed-wettability systems.



fabrication. The substrate is soft baked at  $T = 110\text{ }^{\circ}\text{C}$  for 90 seconds on a direct contact hotplate to remove volatile solvents from the photoresist after coating.

- In the third step, precise alignment of the wettability photomask onto the substrate is achieved using high resolution EVG 6200 Double-side Mask Aligner. Alignment marks are applied to ensure that the wettability patterns are placed accurately on the desired location of the micromodel surface. UV light is subsequently applied to the photoresist-coated wafer through the chrome mask (exposure dose  $200\text{ mJ cm}^{-2}$ , hard mask contact mode,  $80\text{ }\mu\text{m}$  mask/wafer separation gap). This exposure selectively exposes the photoresist not covered by the chrome in the mask, facilitating the transfer of wettability geometric patterns from the photomask to the photoresist material on the substrate. The exposed photoresist under the transparent pattern of the photomask remains undegraded and insoluble to a photoresist developer, while the unexposed photoresist shield by chrome patterns becomes degraded and soluble to the developer. The substrate is placed on a direct contact hotplate for post-exposed baking at  $T = 110\text{ }^{\circ}\text{C}$  for 90 seconds.

- In the fourth step, a bath of AZ-726 photoresist developer is used to selectively remove the photoresist material from the unexposed areas. This selective removal of the unexposed photoresist exposes targeted areas on the substrate surface for hydrophobic coating with precise size, shape, and location.

- The fifth step involves applying a non-selective hydrophobic coating to the entire surface, encompassing both cleared and uncleared regions of the photoresist, using the molecular vapor deposition (MVD) technique. FDTS deposition is conducted utilizing ASMT MVD 100E, a microprocessor-controlled sequential depositor. This process occurs within a controlled gaseous phase, maintained in a precisely regulated environment, ensuring thorough and uniform coverage of the surface. The substrate is placed inside a vacuum chamber and purged multiple times with nitrogen gas. The surface is first activated by  $\text{O}_2$  plasma treatment, and then water vapor is introduced as a catalytic agent. The substrate surface is hydrated by quick adsorption of a water film to promote the attachment of FDTS precursor. FDTS precursors are introduced into the chamber, where a reaction occurs between the activated surface and the reactive precursors. The coating process is carried out at a controlled pressure, which is related to the vapor pressure of the FDTS precursor. The chamber temperature is maintained at  $T = 35\text{ }^{\circ}\text{C}$ , slightly higher than the ambient temperature to prevent condensation of reactants. The concentrations of the precursors, as well as the reaction time, are carefully controlled to ensure a saturated and fully coated surface. In this process, the photoresist layer acts as a protective barrier to the remaining surface during the coating process.

- In the last step, the photoresist layer is removed by immersing the substrate in a bath of NMP solvent bath at  $T =$

$80\text{ }^{\circ}\text{C}$  to lift off the remaining photoresist. Then the substrate cleaned in IPA bath and rinsed with DI water. This step reinstates the original hydrophilic nature of the silicon surface beneath the photoresist layer, preserving the sections directly coated with FDTS. Consequently, a mixed wettability model is established, where the regions coated with FDTS exhibit hydrophobic properties, while the areas without FDTS deposition retain hydrophilicity.

## Results and discussion

The proposed fabrication method was applied to establish mixed wettability micromodel surfaces at the microscale on both plane and pattern surfaces with etched features. The methodology was evaluated using several characterization techniques to investigate the quality and characteristics of the deposited FDTS SAM to alter the substrate wettability.

### Contact angle measurements and wettability assessments

The wettability of the unaltered silicon substrates was initially evaluated to establish the measurement baseline. Sessile drop contact angle measurements using Kruss DSA100 Drop Shape Analyzer system were conducted under ambient conditions to assess the surface and coating macroscopic properties. The average measured contact angle between water and air for a typical sessile droplet with volume of  $V \approx 3\text{ }\mu\text{L}$  on a non-treated silicon substrate was  $\theta = 50^{\circ}$ , confirming that the silicon substrate is originally hydrophilic. The silicon surface wettability might differ slightly depending on the surface finishing and treatment. The surface hydrophilicity is a result of the thin native oxide layer ( $\text{SiO}_2$ ) covering the surface created by oxidation reaction in the air.<sup>59</sup>

As the chemistry of the silicon substrate could have an influence on the thin film deposition and growth process, an investigation was carried out to assess the effect of the cleaning method on the wettability of the silicon surface. The surface cleaned with piranha solution exhibited a lower contact angle of  $\theta = 3^{\circ}$ . This increased hydrophilicity was attributed to surface oxidation and the formation of individual and linked ( $-\text{OH}$ ) groups on the surface, as reported by ref. 60. However, it is important to note that this enhanced surface wettability was not enduring, as the contact angle increased over time due to carbon contamination when exposed to the atmosphere.<sup>59</sup>

Applying an FDTS SAM coating to the silicon surface transformed it into a permanent hydrophobic surface, as evidenced by a measured contact angle of  $\theta = 113^{\circ}$ . This marked a substantial change from the original hydrophilic silicon surface, which had a contact angle of  $\theta = 50^{\circ}$ . The observed decrease in silicon surface energy is attributed to the presence of a strongly fluorinated tail within the FDTS monolayer.



**Table 1** Measured contact angles with FDTS SAM coating surface after different pre-treatment processes

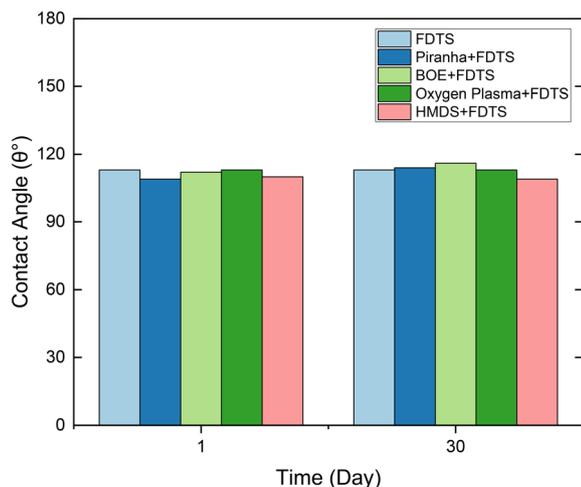
Sample	Contact angle (degree)
FDTS	113
Piranha + FDTS	109
BOE + FDTS	112
Oxygen plasma + FDTS	113
HDMS + FDTS	110

### Sensitivity of coating to pre-treatment

Several experiments were conducted to assess the sensitivity of the deposited FDTS thin layer to surface pre-treatment with piranha, BOE, oxygen plasma, and HDMS, which are commonly used surface conditioning steps during any lithography process. The results of these experiments are summarized in Table 1, confirming a robust FDTS coating. Both piranha and oxygen plasma treatments used to enrich the surface with oxides did not cause further improvement of FDTS SAM deposition. On the other hand, the removal of surface oxides with BOE had no impact on FDTS SAM deposition as surface hydroxylation is already induced by water vapor, the second precursor, during the deposition process. Furthermore, the surface treatment with HDMS, which is usually used to activate the surface during the lithography process, did not affect FDTS adhesion to the silicon substrate.

### Preservation of the wettability alteration

The FDTS-coated surfaces were exposed to ambient conditions in a clean environment for over a month. Results revealed no significant change in the hydrophobicity of the coated surface, where consistent contact angles were obtained, as shown in Fig. 4. This indicates that the chemical stability of the coating is well established through strong

**Fig. 4** Water/air contact angles on FDTS coating aged over 30 days at ambient conditions, which revealed stable wettability with different pretreatments.

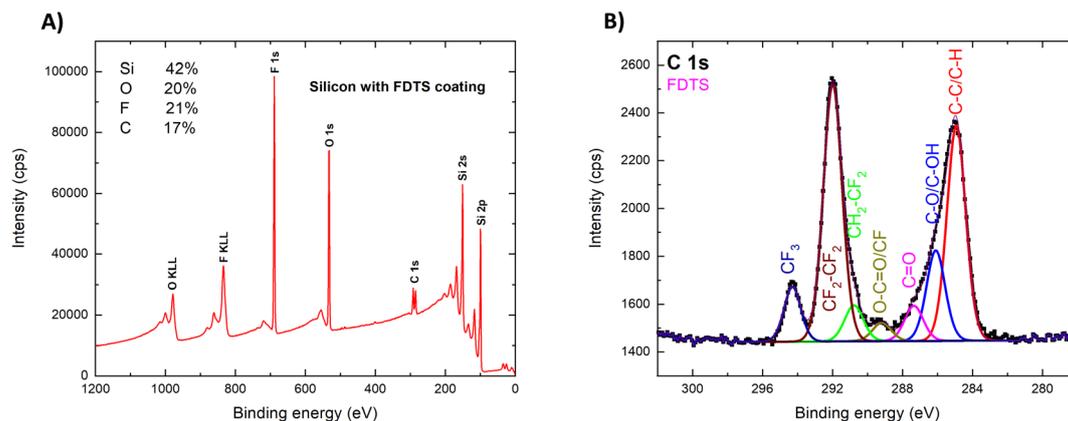
bonding with the surface. The stability observed over several months can be attributed to the absence of substrate oxidation in the surrounding atmosphere, providing clear evidence of the terminated functionality of the grafted FDTS chains. Notably, even with water immersion, there was no detachment due to the penetration of polar molecules through the film, which could disrupt the bonding between the coating and the target surface. Additionally, the film exhibited robust stability when exposed to NMP and IPA solvents, commonly used in the photolithography fabrication process to remove residual photoresist. The results align with previously reported findings for similar coatings.<sup>52,57,61</sup>

### Surface characterization

**Chemical composition.** To further evaluate the coating of the silicon surface with FDTS, surface analysis was conducted using X-ray photoelectron spectroscopy (XPS). The XPS analyses were conducted using a Kratos Axis Supra DLD spectrometer. Fig. 5A displays the XPS spectra peaks, offering insights into the elemental composition present on the surface. The full survey spectrum reveals a clear F 1s peak, O 1s peak, and Si 2s and 2p peaks appeared with intense signals from silicon (Si) and oxygen (O), originating from the SiO<sub>2</sub> substrate. The elemental quantification analysis suggested 42% silicon due to the presence of the silicon substrate and the bonding of silane groups to the surface. The relatively high percentage of oxygen (20%) indicates the presence of residual (OH) groups and multiple (Si–O) bonding, contributing to the native oxide SiO<sub>2</sub> surface. A significant fluorine (F) signal is detected in all investigated regions, indicating the homogeneous coating of the FDTS SAM on the substrate surface. The comparable percentage of fluorine (21%) suggests the presence of long fluorine tails, which are the primary contributors to surface hydrophobicity. Additionally, the presence of carbon (C) (17%) can be attributed to atmospheric contamination. While XPS does not readily detect hydrogen (H) atoms, these qualitative results provide valuable insights into the surface's characterization.

Fig. 5B displays a detailed compositional analysis of the C 1s peak. The XPS spectrum of C 1s confirms the presence of various carbon-related functional groups on the surface. The intense C–C/C–H peak indicates the presence of aliphatic bonds, characteristic of the backbone of the FDTS film. However, it should be noted that there is an additional carbon-related signal present in the spectrum due to hydrocarbon contamination resulting from exposure to air. This contamination is responsible for the appearance of peaks associated with C–O, carbonyl, and carboxyl groups. In addition to the aliphatic bonds and hydrocarbon contamination, the spectrum exhibits peaks corresponding to carbon–fluorine (C–F) bonds. A CF<sub>2</sub> peak indicates the presence of the CF<sub>2</sub> functional backbone group, while the CF<sub>3</sub> peak suggests the presence of a tail group with three fluorine atoms. The high intensity of the CF<sub>2</sub> peak is due to





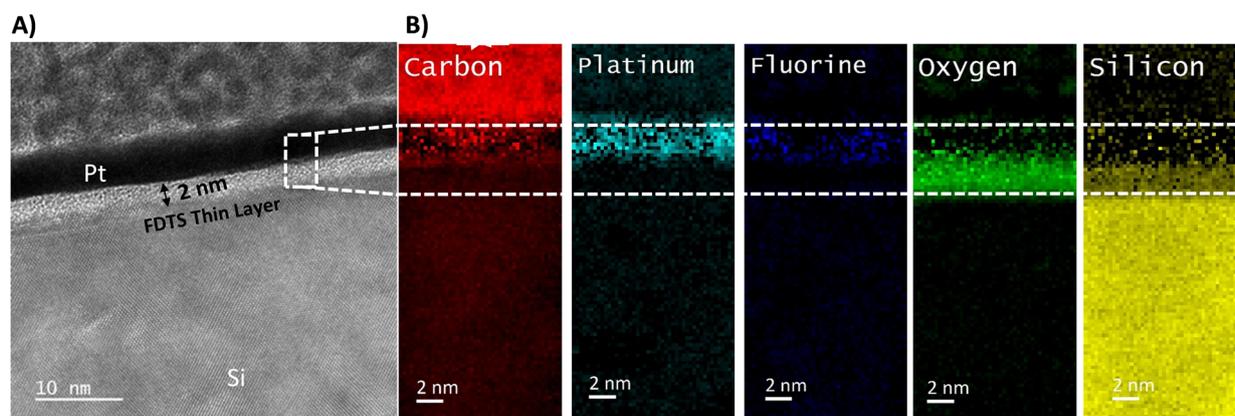
**Fig. 5** A) Full survey XPS spectra of FDTS-coated silicon surface showing elemental composition of the coating film presented on the surface. B) High-resolution spectra of C 1s peak of FDTS-coated silicon surface displays a detailed compositional analysis of functional groups presented on the surface which are consistent with the chemical composition of FDTS SAM.

the deposition of long fluorine chains on the surface. The observed peaks in the XPS spectrum are indicators of the completion of the chemical reaction. The present elements on the surface are consistent with the expected chemical composition of the deposited FDTS film, confirming the presence of carbon, oxygen, silicon, and fluorine elements on the surface.

**Coating layer thickness.** To evaluate the coating film thickness, the surface was characterized using a transmission electron microscope (TEM). The cross-sectional sample was prepared in a Helios G4 Dual Beam system as thin lamellae coated with platinum (Pt). The lamella was lifted-out and thinned to sufficient electron transparency (<100 nm). The analysis was conducted using an aberration-corrected TEM of model Cs probe from ThermoFisher Scientific that was equipped with a post-column electron energy loss spectroscopy (EELS) equipment of model GIF-Quantum 966 from Gatan, Inc. Fig. 6A shows a cross-sectional view of the coated surface. The TEM image shows a uniform deposition of a thin amorphous layer of FDTS coating with a thickness of 2 nm on the top of the silicon substrate. Furthermore, the

elementary compositional map was performed across the film, as appears in Fig. 6B, displaying the color-coded images of each element within the layer thickness. The Si color signal is clearly presented in the map due to the base Si substrate. An associated overlapped thin layer of oxygen with Si layer is also presented on top of Si substrate as a result of the existence of multiple (Si-O) bonding highlighting both the FDTS molecules' head groups and the hydrated surface. The coexistence of F and C color signals represents the extended aliphatic fluorinated tails of the FDTS molecules. The Pt and C overlapped signal is expected due to the penetration of the Pt-C between the molecules' tails during lamella sample preparation. The highly intense C signal at the top is from the layer generated during the process of Pt sputter coating using Pt precursor gas.

**Surface morphology.** Atomic force microscopy (AFM) measurement was employed to evaluate the surface morphology. The measurement was performed using tapping imaging mode in Bruker's Dimension Icon AFM. Fig. 7 shows  $7 \times 6 \mu\text{m}$  2D and 3D topography images of the mixed wet-



**Fig. 6** A) TEM image showing a 2 nm thin film coated on a silicon substrate. B) Elemental compositional map highlighting the intensity and distribution of Si, O, F, Pt, and C elements across the deposited film.



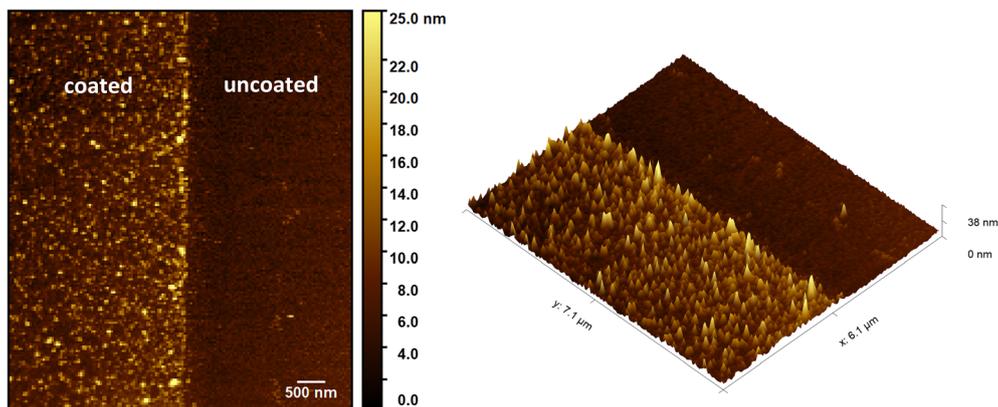


Fig. 7 AFM 2D and 3D  $7 \times 6 \mu\text{m}$  topography image of the mixed-wet surface showing a distinct difference between coated and uncoated regions of the substrate.

coated silicon. These images reveal a noticeable shift in surface properties, marked by a distinct boundary between the coated and uncoated regions of the substrate. The calculated root mean square (RMS) roughness showed slightly higher RMS roughness for the coated side of 3 nm compared to 2 nm for the uncoated side. Therefore, the surface demonstrated good smoothness with just 1 nm difference in roughness induced after coating. These results affirm the successful deposition of high-quality, smooth, and uniformly coated surfaces at the microscale, characterized by a distinct and precise interface between the coated and uncoated regions. Establishing a thin, smooth, and uniform

coating is essential for regulating pore sizes and preventing unintended fluid disruptions caused by irregular surface roughness.

#### Assessment of mixed wettability

To validate the effectiveness of the proposed method for achieving mixed wettability, we conducted tests on both a flat surface and a more complex micro-model.

**Wettability alteration on flat surface.** To demonstrate the process, we designed a wettability pattern photomask with square patterns (see Fig. 8A). This design consists of square

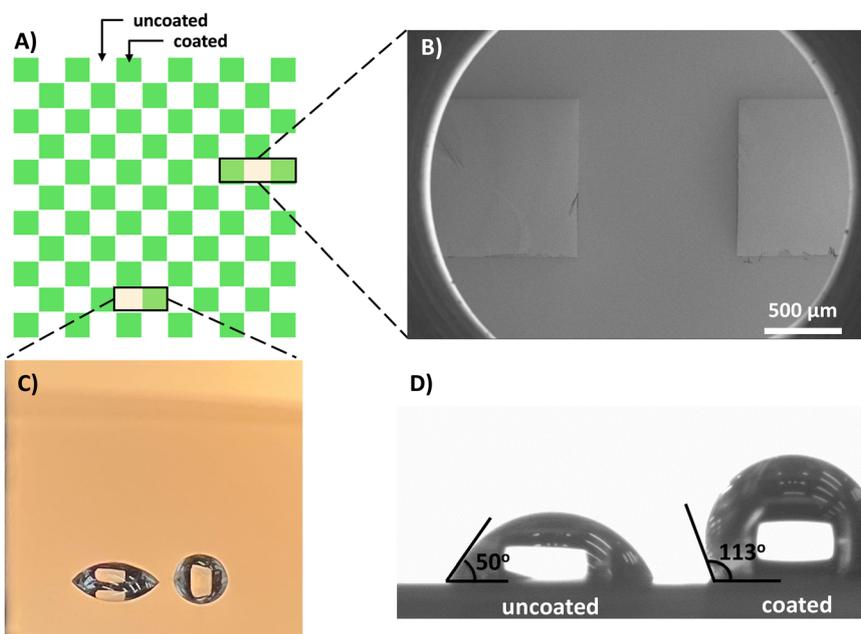


Fig. 8 A) The wettability photomask design with alternating square patterns with a size of  $1 \text{ mm} \times 1 \text{ mm}$ . The shaded squares represent the regions to be coated with a hydrophobic layer, while the remaining areas remain uncoated and hydrophilic. B) SEM image revealing the coated regions as distinct square patterns on top of the silicon surface. C) Side view of two water droplets of the same volume placed on different spots of the same silicon wafer illustrating mixed wettability feature. The droplet on the left is positioned on the uncoated region, while the droplet on the right is placed on the coated region. D) The contact angles of adjacent water droplets on both the uncoated (left,  $\theta = 50^\circ$ ) and coated (right,  $\theta = 113^\circ$ ) regions on the same substrate show a noticeable shift in contact angles measured.



patterns with a size of  $1\text{ mm} \times 1\text{ mm}$ , arranged in alternating sequence. The shaded squares denote regions designated with a hydrophobic coating, whereas the unshaded regions stay uncoated and maintain their hydrophilic properties. This layout demonstrates the distinct distribution of hydrophobic and hydrophilic regions, as illustrated in Fig. 8A. To evaluate the consistency and precision of the mixed-wettability boundaries at the microscale, scanning electron microscopy (SEM) was used. The SEM topography image taken after finalizing the coating process is shown in Fig. 8B. The image reveals the coated regions as distinct square patterns selectively placed on the exposed areas of the substrate during the photolithography fabrication, following the prescribed wettability pattern photomask. The remaining surface, protected by the photoresist, remained uncoated. This SEM image effectively demonstrates the application of selective hydrophobic coating. Fig. 8C provides a side view of two droplets of the same water volume deposited on different spots with contrasting wettability on the same silicon surface. The droplet on the left was placed on the uncoated region, while the droplet on the right was placed on top of the coated region. This arrangement provides a visual contrast of the wettability variations between the two regions. The droplet on the hydrophilic uncoated area had an angle of  $\theta = 50^\circ$ , while the one on the adjacent hydrophobic coated area had an angle of  $\theta = 113^\circ$ , as shown in Fig. 8D.

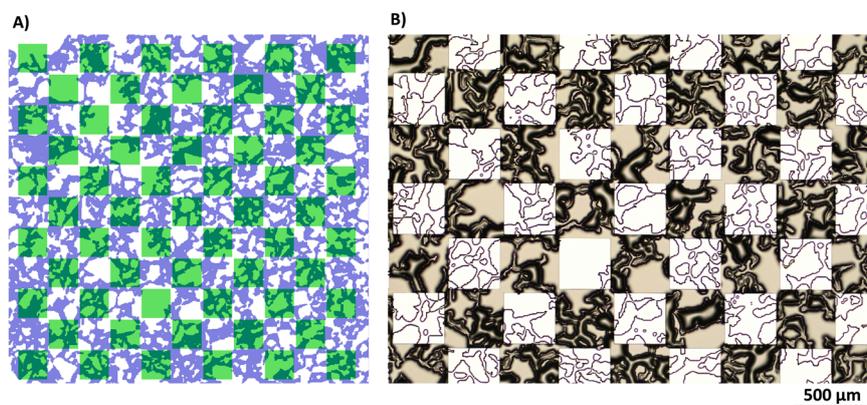
**Wettability alteration on complex model.** We applied the proposed methodology to a heterogeneous rock-patterned micromodel (purple layer) as illustrated in Fig. 9A. The same wettability pattern is applied to the top surface of the micromodel, consisting of finer square patterns with a size of  $260\text{ }\mu\text{m}$  and a spacing of  $300\text{ }\mu\text{m}$ . The motivation is to demonstrate precise positioning, shaping, and distribution of wetting and non-wetting regions within a complex microscale geometry during the soft lithography process at a microscale. This necessitated careful adjustment of photolithography parameters, including resist viscosity, spinning speed, and UV exposure intensity,

to ensure uniform coating of the photoresist on all features of the micromodel surface. The microscopic image of the actual fabricated micromodel (see Fig. 9B) highlights the selective and sharp opening of the desired areas (white squares) in the photoresist coating the micromodel during the photolithography process. This involved selectively removing the photoresist from all micromodel features, including surfaces and channels, located beneath these square patterns. The remaining areas are remained shielded with photoresist (beige areas) to prevent hydrophobic coating beneath it, while the black regions indicate the light reflection of channels edges covered with the photoresist. Successful removal of any residual photoresist was crucial for the subsequent FDTs coating stage, underscoring the precision of this fabrication process at the microscale.

Fig. 10A shows a top-view image of the fabricated mixed-wet system using SEM. The image highlights the accurate placement of the selected coated zones on the top of the micromodel at the microscale. The size, shape, and location of these regions precisely match the predetermined design of wettability patterns. Fig. 10B displays a zoomed image of a narrow channel within the micromodel, which demonstrates the coating of all small features with an average depth dimension of  $14.5\text{ }\mu\text{m}$ . This included the precise coating of all surfaces positioned beneath the wettability patterned shadow. The image illustrates the distinction between the coated and uncoated areas, affirming the successful achievement of a conformal coating with uniform coverage along the edges for both the body and wall surfaces of the channels.

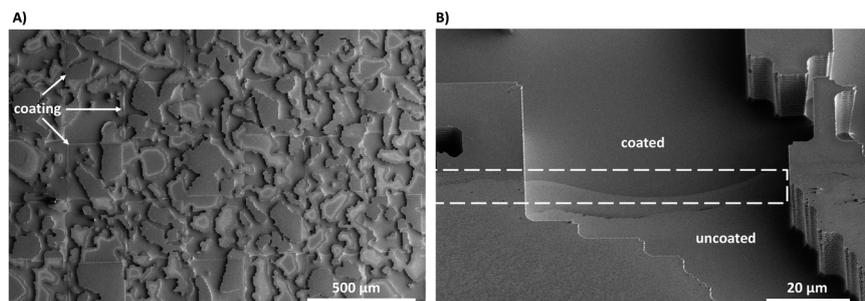
### Flow in single mixed-wet channel

To assess the efficacy of the introduced coating method in microfluidics, a basic flow-through experiment was conducted to observe the influence on fluid behavior and dynamic contact angle. A  $100\text{ }\mu\text{m}$  capillary channel with two wettability configurations was prepared following the



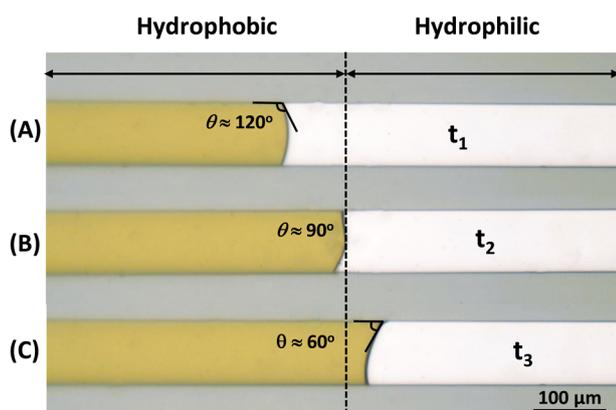
**Fig. 9** A) The design of the wettability patterns applied on the top of a micromodel surface. B) Microscopic image showing the selective and sharp opening of photoresist on the top of the actual fabricated micromodel following the same wettability pattern at microscale.





**Fig. 10** A) SEM image of the actual fabricated mixed-wet micromodel showing selected coated zones. B) Enlarged SEM image highlighting the dimensions and selectivity of the coated and uncoated zones within narrow channels.

proposed fabrication protocol. Fig. 11 displays the microscale model, divided into two distinct regions: one half, on the left side, exhibits hydrophobic properties, while the other is hydrophilic. DI water, colored for visualization clarity, was introduced into the channels. Observations were made at different time intervals ( $t_1$ ,  $t_2$ , and  $t_3$ ) to monitor the fluid's progression. At  $t_1$ , the fluid is still within the hydrophobic region (Fig. 11A). At  $t_2$ , the fluid is approximately at the interface between the hydrophobic and hydrophilic regions (Fig. 11B), and at  $t_3$ , the fluid is within the hydrophilic region (Fig. 11C). During these three stages, the water's meniscus undergoes transitions from a convex shape ( $\theta = 120^\circ$ ) in the hydrophobic region, almost neutral ( $\theta = 90^\circ$ ) at the interface, to a concave shape ( $\theta = 60^\circ$ ) in the hydrophilic region. While the meniscus displays a transient shape at the interface between the hydrophobic and hydrophilic regions due to changes in the wetting state, the noticeable variation in the apparent contact angle of water signifies a clear influence of distinct surface wettability on the behavior of the fluid displacement front in the meniscus. These observations underscore the efficacy of the method in precisely controlling the wettability of the micromodel.



**Fig. 11** Single capillary micromodel with hydrophobic coating on the left half and hydrophilic uncoated surface on the right half. The dynamic contact angle of water displacement front shows an evident change in meniscus behavior from a convex shape ( $\theta = 120^\circ$ ) in the hydrophobic region (A), to neutral ( $\theta = 90^\circ$ ) at the interface (B), to a concave shape ( $\theta = 60^\circ$ ) in the hydrophilic region (C).

## Conclusions

The work introduces a novel methodology for creating microfluidic devices with mixed-wettability surfaces. This technology allows for precise placement of hydrophilic and hydrophobic zones at the pore scale, effectively representing the complex mixed wettability observed in reservoir rocks. In contrast to other surface modified manufacturing method of micromodels, our approach provides several notable advantages, including stable, controlled, reliable, and reproducible fabrication. This ensures the execution of robust experiments with precise control over wettability. Our method integrates soft lithography with thin-film deposition techniques. Using a silicon substrate, we optimized the photolithography process and altered wettability through perfluorodecyltrichlorosilane coating *via* molecular vapor deposition. This process made specific microdevice areas hydrophobic while keeping others unchanged. To evaluate the coating's effectiveness, we measured contact angle, X-ray photoelectron spectroscopy, and various microscopy techniques, which confirmed the effectiveness of the proposed method. While the current work focuses on altering wettability within reported ranges of contact angles, the technology holds the potential for extension to achieve customized contact angles by employing different coating materials while following the same methodology. Finally, this work serves as a demonstration of the technique's capabilities and highlights its potential for various applications, such as microfluidics, lab-on-a-chip devices, and biomimetic systems. Future work will focus on applying this method in varied contexts, such as multiphase fluid flow and  $\text{CO}_2$  sequestration.

## Abbreviations

FDTS	Perfluorodecyl-trichlorosilane
UV	Ultraviolet
SAM	Self-assembly monolayer
DI	Deionized water
HMDS	Hexamethyldisilazane
BOE	Buffered oxide etch
NMP	<i>n</i> -Methyl-2-pyrrolidone solvent
IPA	Isopropyl alcohol



XPS	X-ray photoelectron spectroscopy
TEM	Transmission electron microscopy
AFM	Atomic force microscopy
SEM	Scanning electron microscopy
RMS	Root mean square roughness

## Author contributions

Abdullah AlOmier: methodology, investigation, fabrication, experiments, visualization, data analysis, writing – original draft. Dongkyu Cha: conceptualization, methodology, data analysis, writing – review & editing. Subhash C. Ayirala: data analysis, verification, writing – review & editing. Ali Al-Yousef: verification, supervision, editing and review. Hussein Hoteit: supervision, methodology, verification, writing – review & editing.

## Conflicts of interest

There are no conflicts of interest to declare.

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